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MAY 12 2006

Docket No.: 2336-256

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Ju Hyun KIM et al.

U.S. Patent Application No. 10/810,634

Filed: March 29, 2004

Confirmation No.: 9586

Group Art Unit: 2823

Examiner: FERNANDO L TOLEDO

For: METHOD FOR SEPARATING SAPPHIRE WAFER INTO CHIPS USING DRY-ETCHING

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

- ☐ No additional fee is required.
- ☐ Small entity status of this application has been established.
- ☐ Also attached:

The fee has been calculated as shown below:

| | NO. OF CLAIMS | HIGHEST PREVIOUSLY PAID FOR | EXTRA CLAIMS | RATE | FEE |
|--|------------------|-----------------------------------|-----------------|-----------|------------------|
| Total Claims | 20 | 20 | 0 | x \$ 50 = | \$ 0.00 |
| Independent Claims | 4 | 3 | 1 | x \$200 = | \$ 200.00 |
| If multiple claims newly presented, add \$360.00 | | | | | |
| Fee for extension of time | | | | | |
| TOTAL FEE DUE | | | | | \$ 200.00 |

- ☒ A credit card authorization form in the amount of \$ 200.00 is attached
- ☒ The Commissioner is hereby authorized to charge payment of any *deficiency* in fees associated with this communication or credit any overpayment, to Deposit Account No. 07-1337, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

LOWE HAUPTMAN & BERNER, LLP

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 Date: May 12, 2006

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Docket No.: 2336-256

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Ju Hyun KIM *et al.* : Confirmation No. 9586
U.S. Patent Application No. 10/810,634 : Group Art Unit: 2812
Filed: March 29, 2004 : Examiner: Fernando L Toledo
For: METHOD FOR SEPARATING SAPPHIRE WAFER INTO CHIPS USING DRY-
ETCHING

AMENDMENT

COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria VA 22313-1450

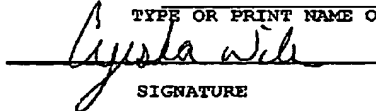
Sir:

The following amendments and remarks are submitted in response to the Official Action dated February 13, 2006.

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